



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2005 \$17.46

PATENT

PATENT & TRADEMARK OFFICE

Mikhaylich et al.

Application No: 10/766,733

Filed: January 27, 2004

For: METHOD AND SYSTEM FOR CLEANING
A SEMICONDUCTOR WAFER

) Attorney Docket No: LAM1P108D
)
) Examiner: MARKOFF, A.
)
) Group Art Unit: 1746
)
) Date: March 15, 2005
)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on March 15, 2005.

Signed: 
Michael L. Gencarella

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims Remaining After <u>Amendment</u>	Highest Previously <u>Paid For</u>	Present <u>Extra</u>	SMALL ENTITY <u>RATE FEE</u>	OR	LARGE ENTITY <u>RATE FEE</u>
TOTAL						
CLAIMS	<u>16</u>	<u>-</u>	<u>20</u>	<u>00</u>	X25 = \$	OR X50 = \$
INDEP						
CLAIMS	<u>2</u>	<u>-</u>	<u>03</u>	<u>00</u>	X100 = \$	OR X200 = \$
[] Multiple Dependent Claim Present and Fee Not Previously Paid				\$180		X360 \$
			TOTAL	\$ _____		\$ _____



Applicant(s) hereby petition for a month(s) extension of time to respond to the outstanding Office Action. Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM1P108D).

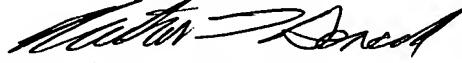


Enclosed is our Check No. in the amount of to cover the additional claim fee and/or extension of time fees.



If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM1P108D). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE, PENILLA & GENCARELLA, LLP



Michael L. Gencarella, Esq.
Registration No. 44,703

710 Lakeway Drive, Suite 200
Sunnyvale, CA 94085
Telephone: (408) 774-6921
Customer Number 25920



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Mikhaylich et al.

Application No: 10/766,733

Filed: January 27, 2004

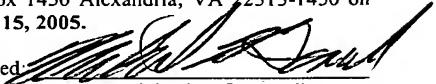
For: METHOD AND SYSTEM FOR CLEANING
A SEMICONDUCTOR WAFER

) Attorney Docket No: LAM1P108D
)
)
) Examiner: MARKOFF, A.
)
)
) Group Art Unit: 1746
)
)
) Date: March 15, 2005
)
)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on **March 15, 2005**.

Signed:



Michael L. Gencarella

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

This Amendment is in response to the Office Action mailed on December 15, 2004. Please enter the following amendments and remarks in the above-identified patent application:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.